

Search Notes



Application/Control No.

10/826,267

Examiner

David Y. Chung

Applicant(s)/Patent under Reexamination

KIM ET AL.

Art Unit

2871

SEARCHED

Class	Subclass	Date	Examiner
349	129	2/21/2005	DC
349	130	2/21/2005	DC
349	122	2/21/2005	DC
349	138	2/21/2005	DC
349	139	2/21/2005	DC
updated	updated	8/5/05	DC

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
same	same	8/5/05	DC

SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR
EAST search report	2/21/2005	DC
Consulted Ken Parker regarding allowable subject matter	2/21/2005	DC
	8/5/05	P